



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 2538

<b>SERIAL NUMBER</b> 10/801,821	<b>FILING OR 371(c) DATE</b> 06/22/2004 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2812	<b>ATTORNEY DOCKET NO.</b> 111587.01
------------------------------------	-----------------------------------------------------------	---------------------	-------------------------------	-----------------------------------------

## APPLICANTS

Fumio Koyama, Yokohama-shi, JAPAN;  
 Nobuaki Ueki, Ebina-shi, JAPAN;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a DIV of 10/026,637 12/27/2001 PAT 6,990,128

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2001-91351 03/27/2001  
 JAPAN 2001-285964 09/19/2001

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 07/23/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 20	<b>TOTAL CLAIMS</b> 5	<b>INDEPENDENT CLAIMS</b> 1
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature: <i>[Signature]</i> Initials: <i>[Initials]</i>				

**ADDRESS**  
 25944

## TITLE

Surface emitting semiconductor laser and manufacturing method thereof

<b>FILING FEE RECEIVED</b> 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
		<input type="checkbox"/> 1.16 Fees ( Filing )
		<input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
		<input type="checkbox"/> 1.18 Fees ( Issue )
		<input type="checkbox"/> Other _____
		<input type="checkbox"/> Credit